



Patent  
Atty. Docket: H60-099 US

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**CERTIFICATE OF MAILING**

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*Annita Lise*  
Annita Lise  
Dated: March 4, 2003

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Hans Martin BUSCHBECK, et al  
Serial No. : 09/975,885  
Filing Date : October 12, 2001  
Examiner : Matthew J. Song  
Group Art Unit : 1765

For : METHOD FOR PRODUCING COMPONENTS  
AND ULTRAHIGH VACUUM CVD REACTOR

**Box Non-Fee Amendment  
Commissioner for Patents  
Washington, D.C. 20231**

**ELECTION**

Sir:

In response to the Restriction Requirement mailed February 4, 2003, please amend the above-identified application as follows:

**IN THE CLAIMS:**

Please cancel Claims 69-93.

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TC 1700 MAIL ROOM